

Mechanical Behavior of Electrodeposited Copper Film at Elevated Temperatures

D. T. Read, Y.-W. Cheng, R. Geiss

Materials Reliability Division

National Institute of Standards and Technology

Boulder, Colorado 80305

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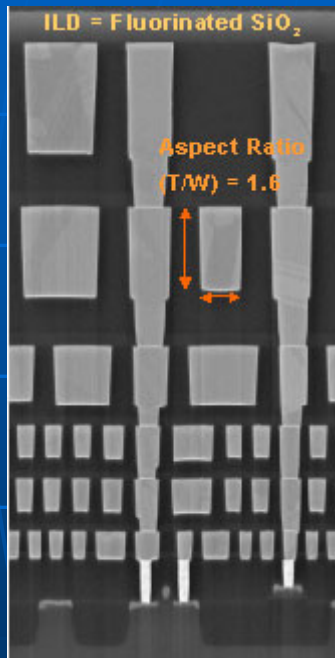
Summary:

- Tensile behavior measured for 2.6 μm thick electrodeposited Cu, room temperature to 150 $^{\circ}\text{C}$
- Modulus values results low, but uncertainty high in this technique
- Strengths 200-300 MPa
- Low tensile ductility
- Temperature dependence of strengths moderate, in the expected direction
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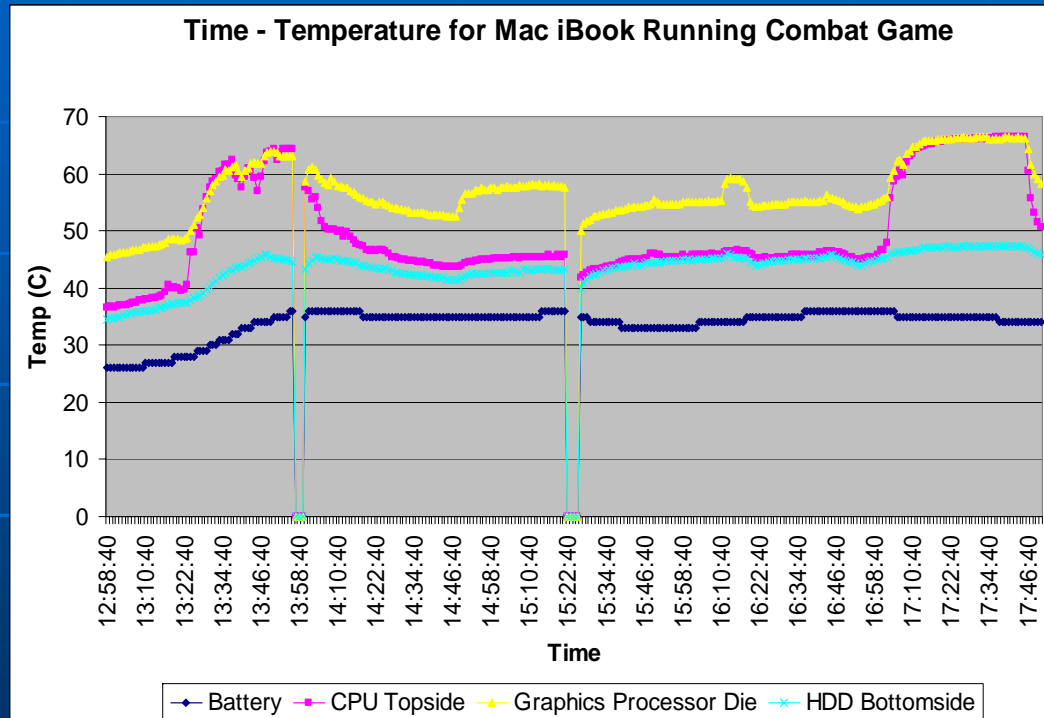
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Motivation:

Data for design of electronic interconnects



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Material:

Electrodeposited copper

Seed:

thermally evaporated;
60 nm thick on bare silicon

Grain size:

$> \sim 1 \mu\text{m}$ (EBSD)

Solution:

Conventional acid-based,
with brightener

Texture:

Film plane
normal is $\langle 111 \rangle$

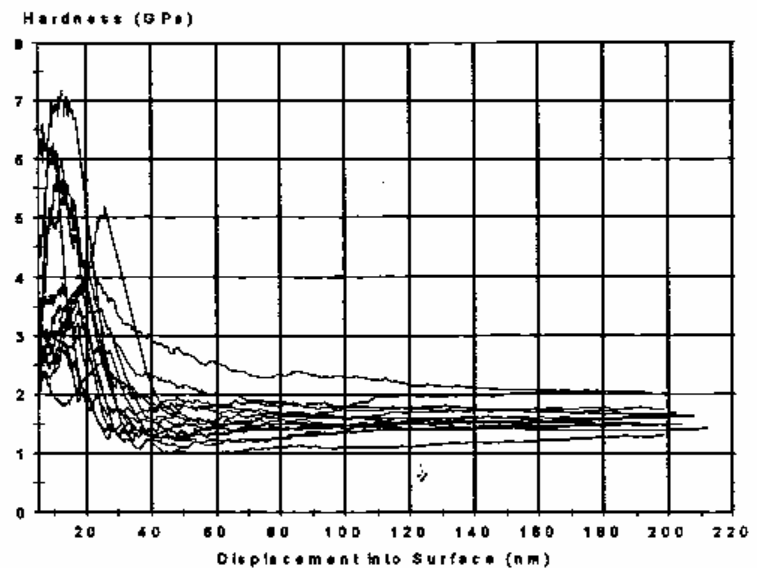
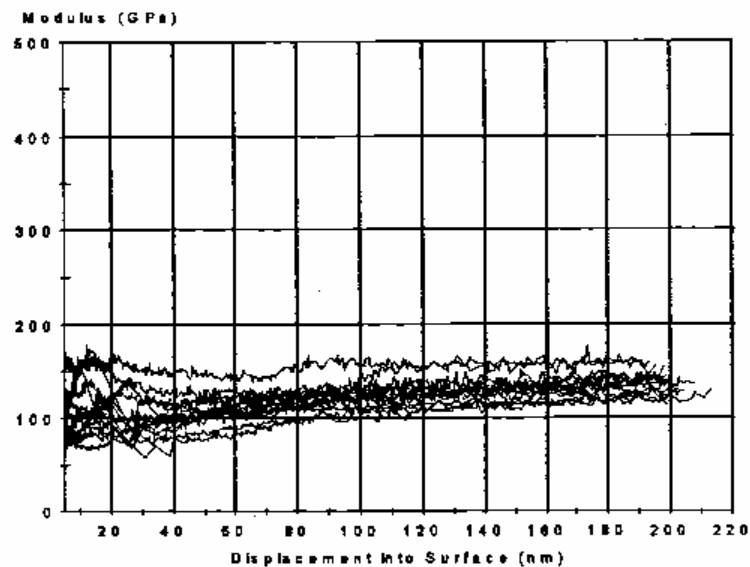
Thickness:

$2.6 \mu\text{m}$

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Material, continued:

Commercial high-precision nanoindentation instrument:

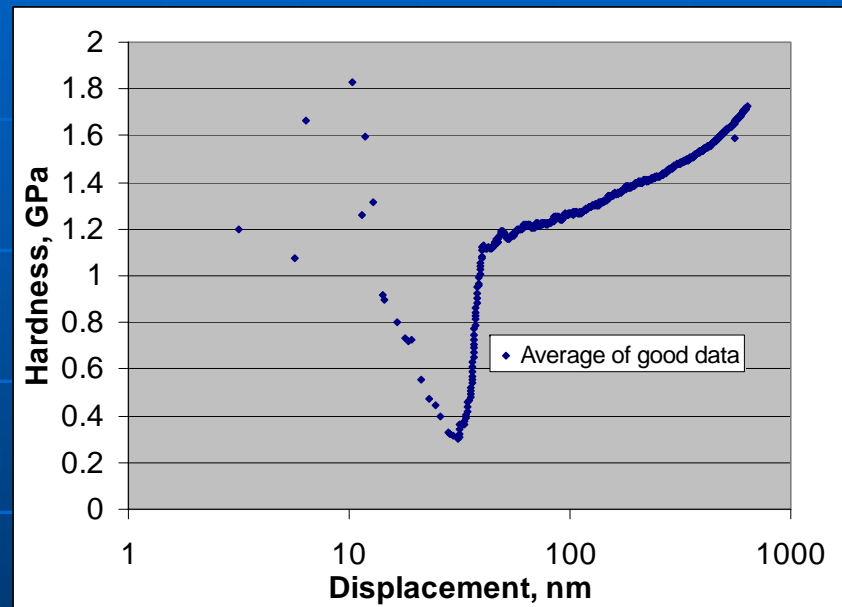
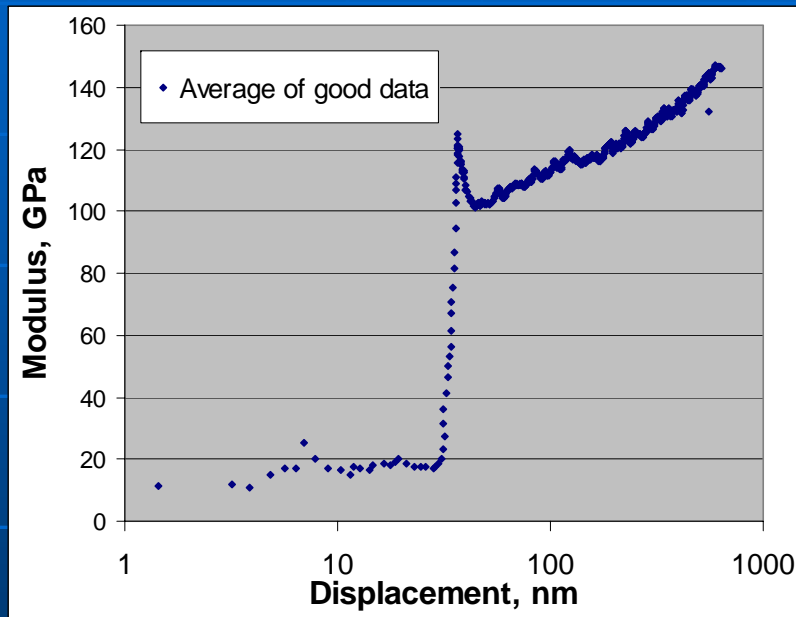


Modulus: 125 ± 9 GPa, Hardness: 1.54 ± 0.11 GPa

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Material, continued:

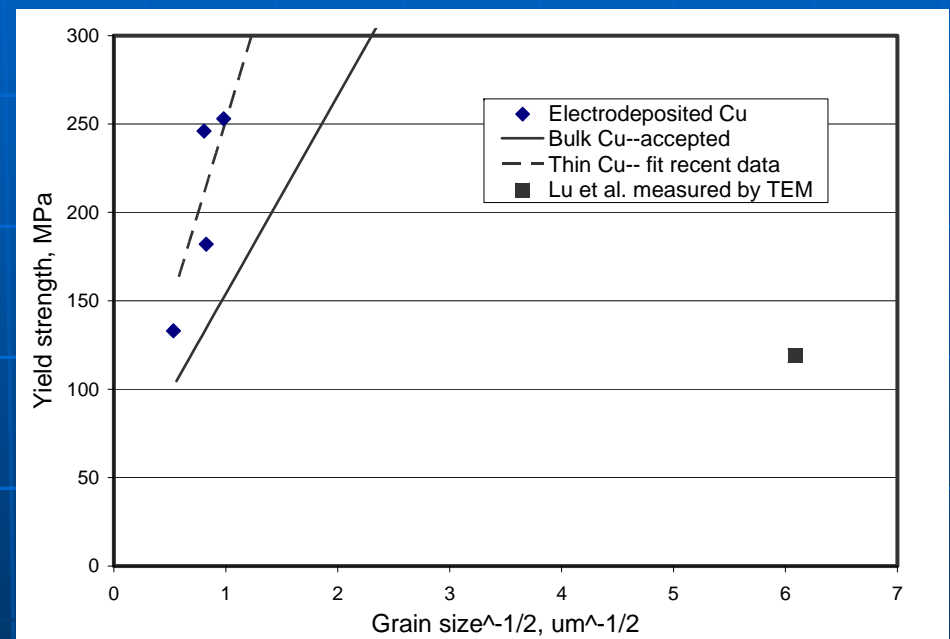
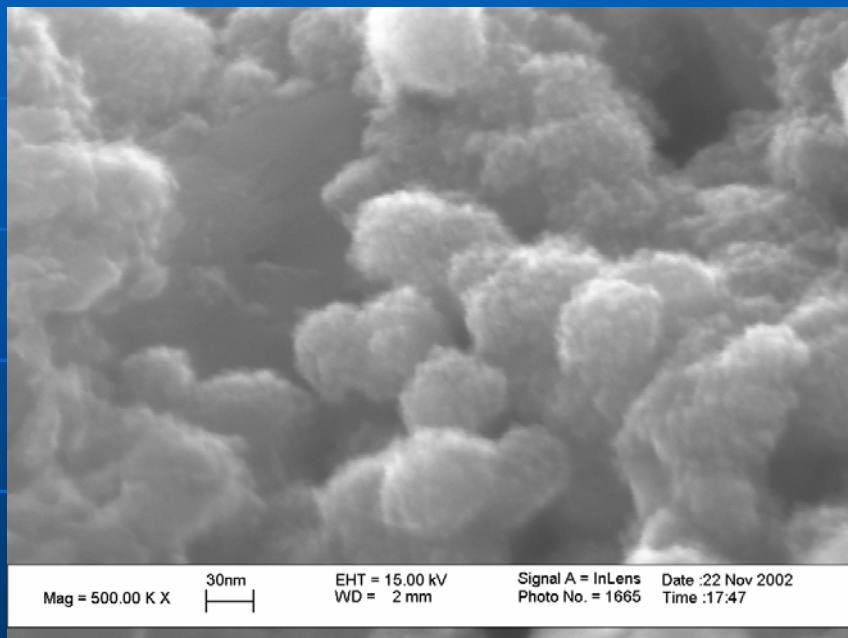
Commercial nanoindentation instrument (aged):



Modulus: 122 ± 6 GPa, Hardness: 1.40 ± 0.08 GPa

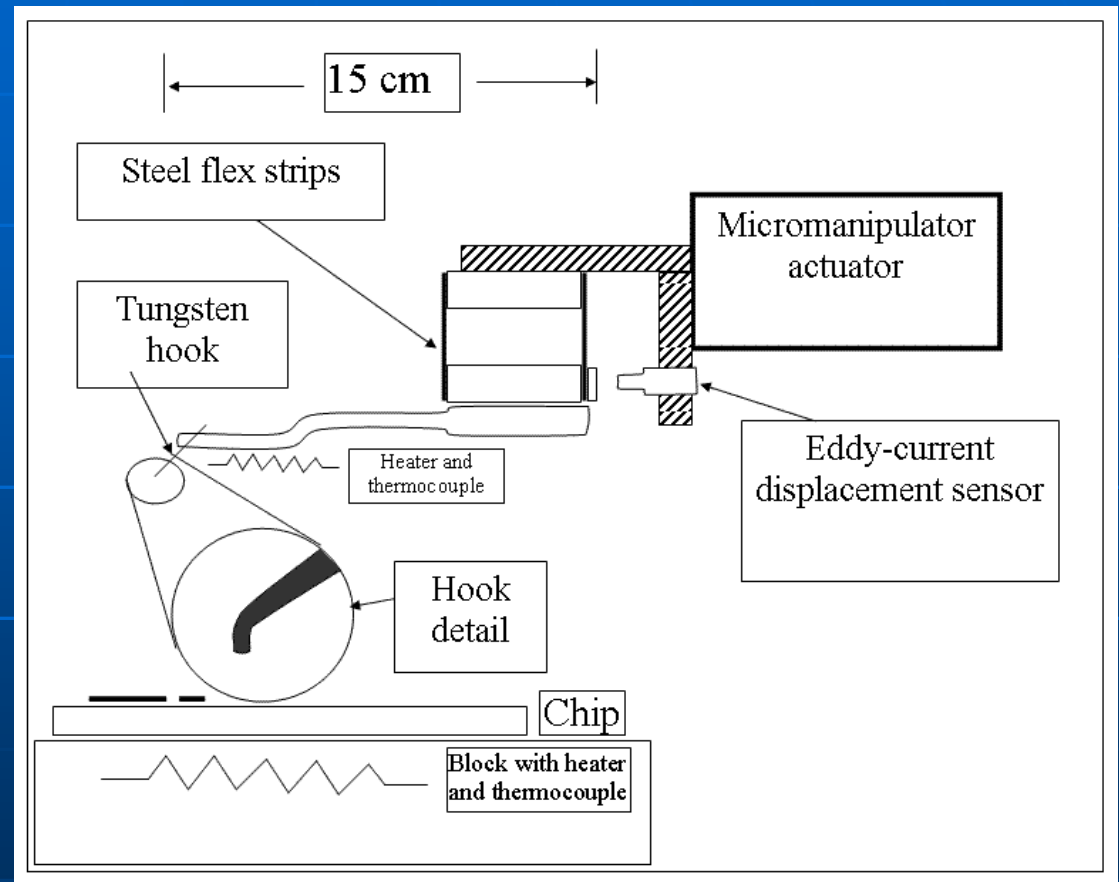
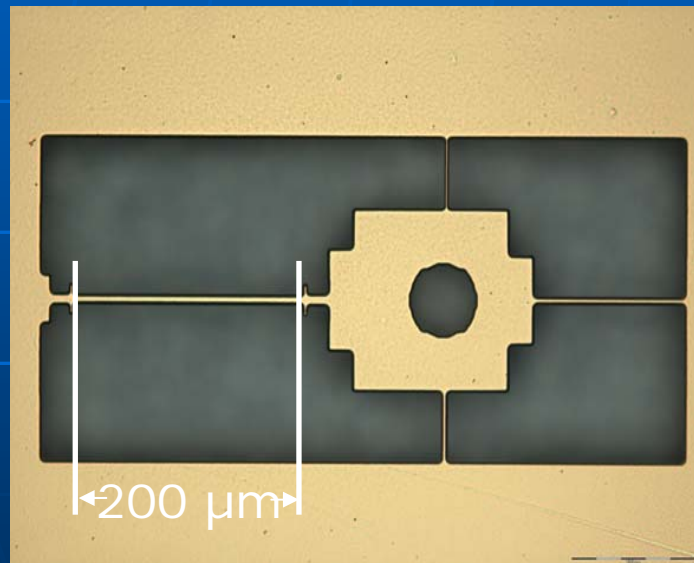
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Material, continued:



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Method: Microtensile testing



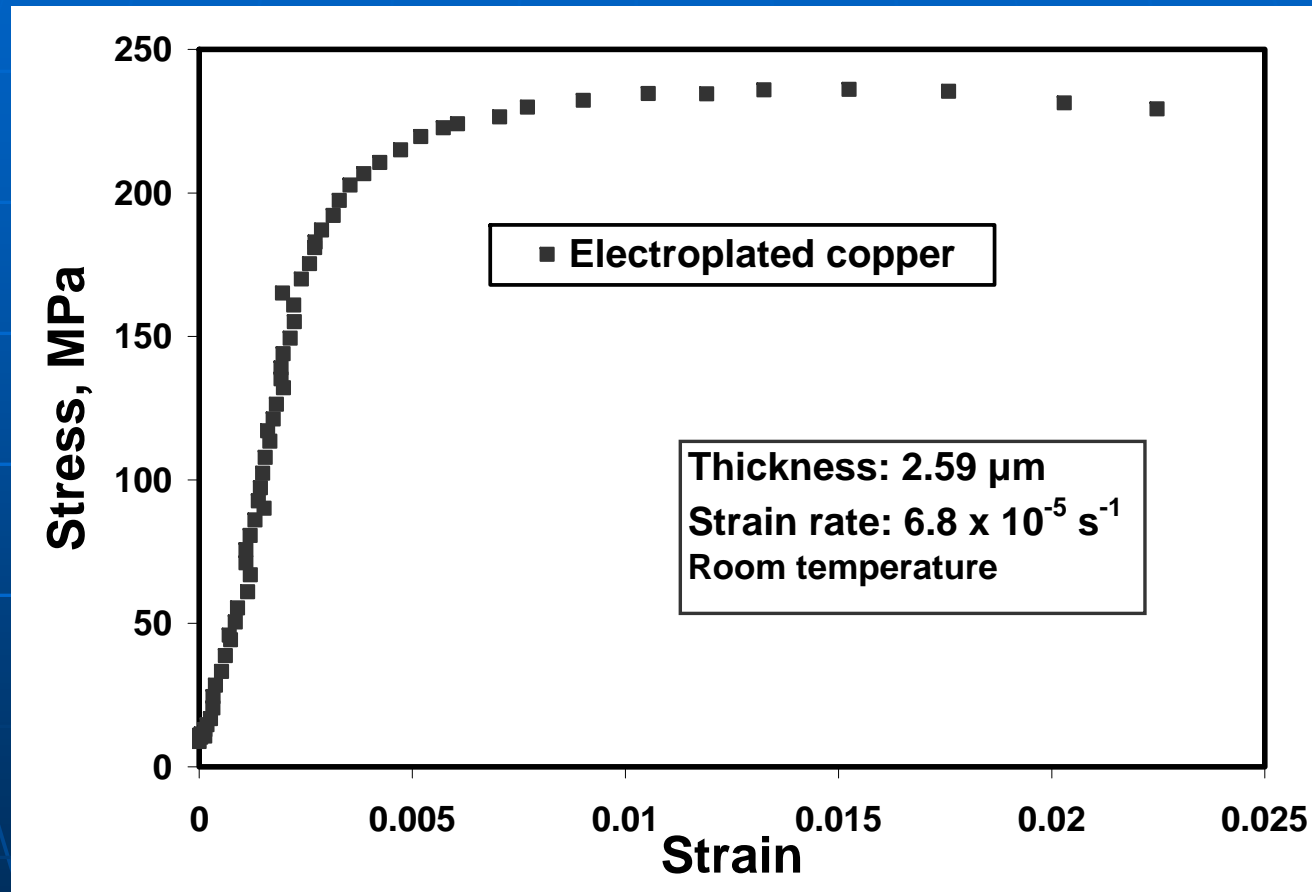
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Method, continued:

Force:	Calibrated spring on force probe
Displacement:	Digital image correlation
Specimen dimensions:	Profilometer, optical microscope
Temperature:	Thermocouples beneath chip and on pull rod

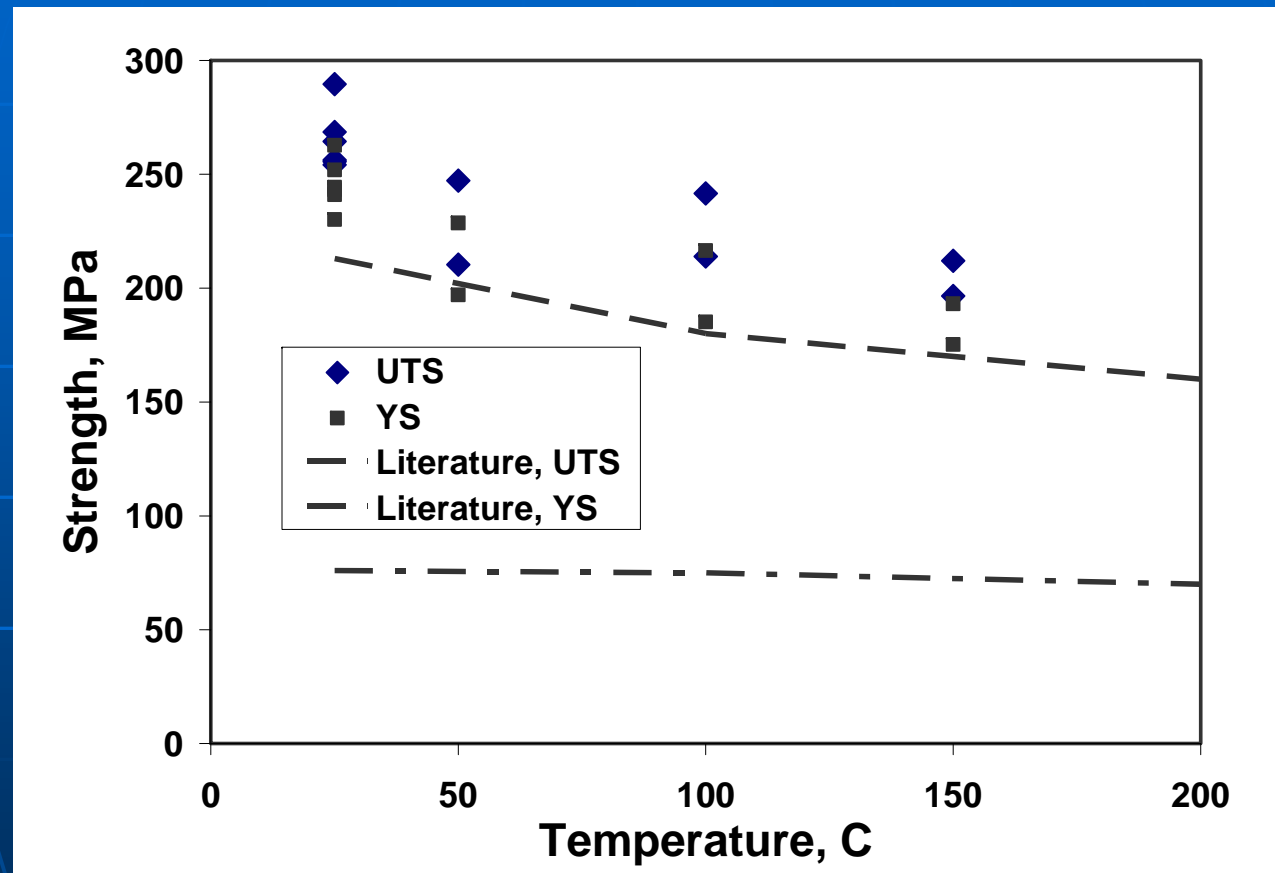
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Results: Stress-strain curves



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Results: Temperature dependence



Literature: Carreker and Hibbard, *Acta Metallurgica* 1 654-663, 1953

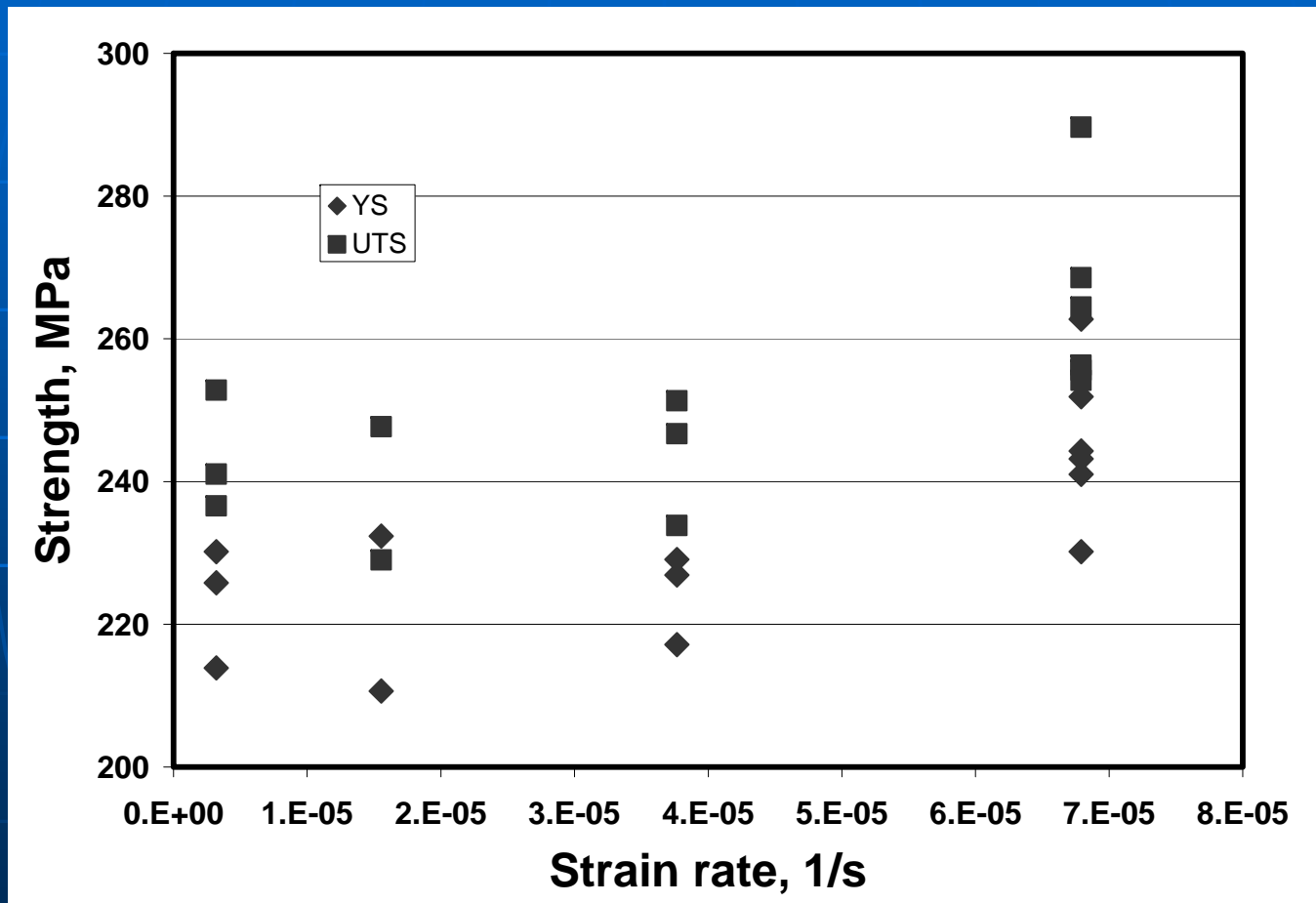
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Results: Moderate temperature dependence;
 High strength vs pure annealed bulk;
 Low tensile elongation to failure;
 High variability of Young's modulus, E

Temp., C	Number of tests	YS, MPa	UTS, MPa	E, GPa	Elong., %
25	18	234±16	257±17	72±22	2.2±0.7
50	2	213±22	229±26	NA	1.5±0.2
100	2	201±22	228±20	82±3	1.7±0.07
150	3	184±13	204±11	82±24	2.2±1.1

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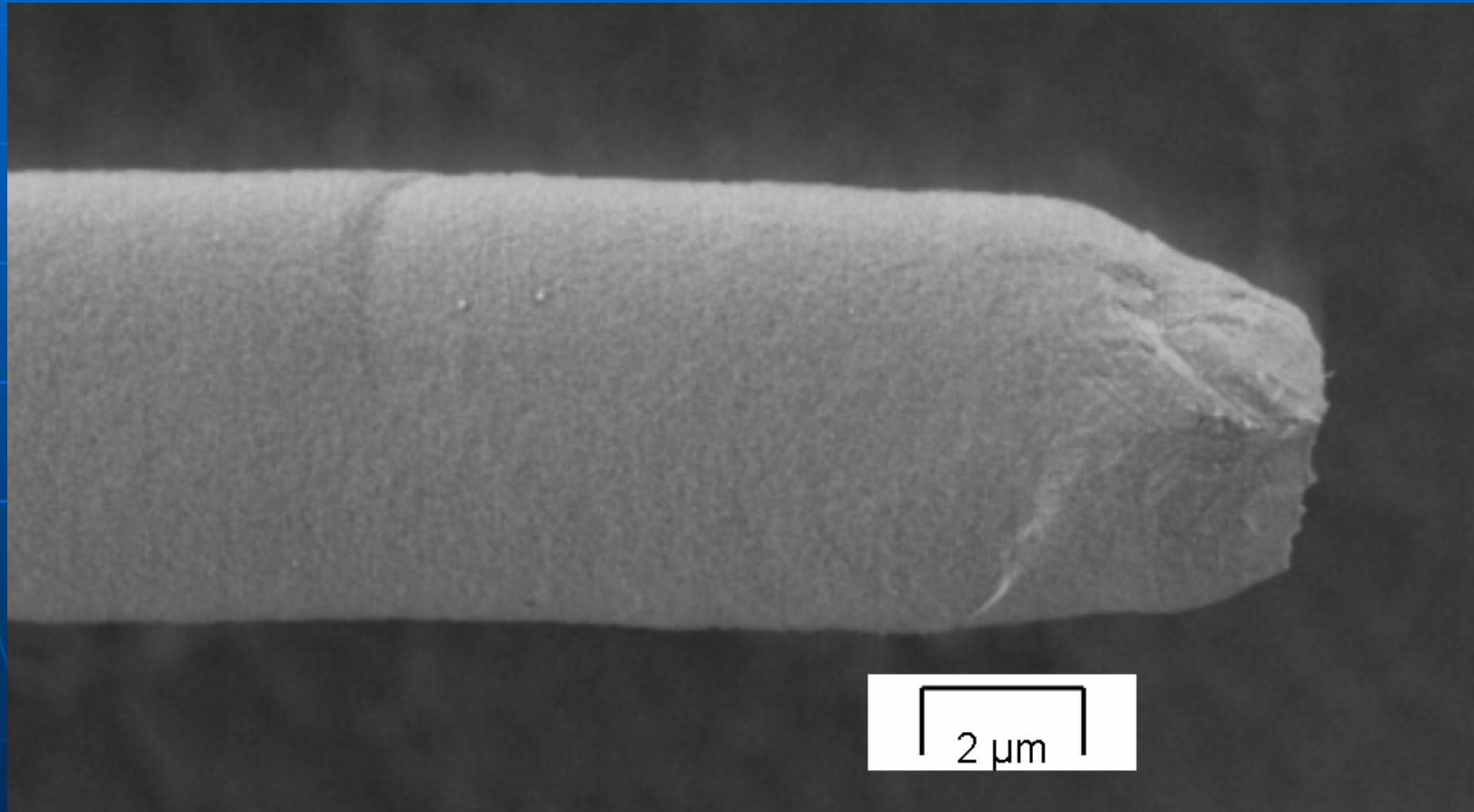
Results: Strain rate effect on strength at room temperature is moderate to minimal



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Results: Fractography (1), top view

>>>> local necking; chisel-point failure



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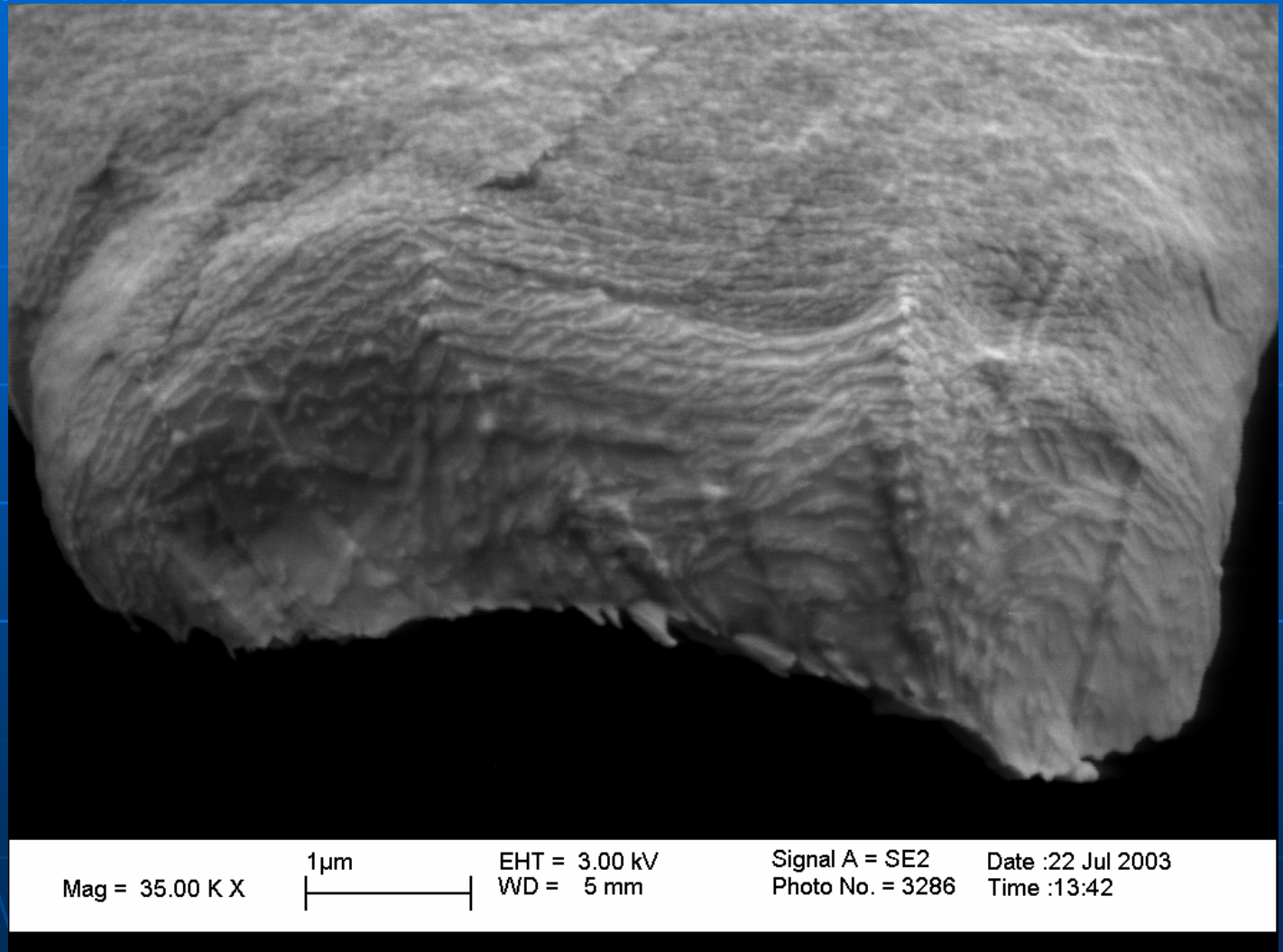
Results: Fractography (2), end view

Strange surface features—

metallographic,

????????????????

or reptilian?



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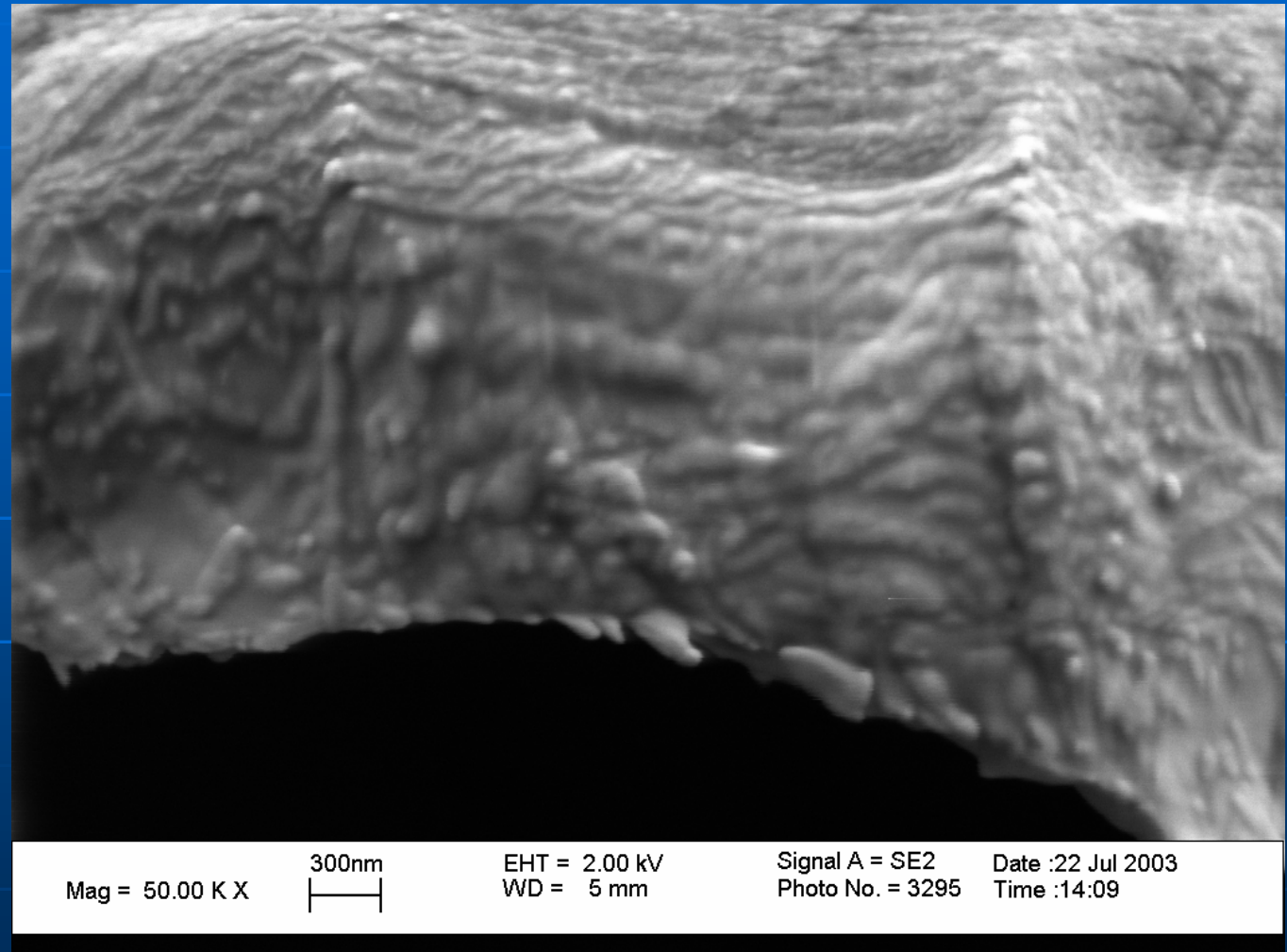
Results: Fractography (3), end view

Strange surface features—

metallographic,

????????????????

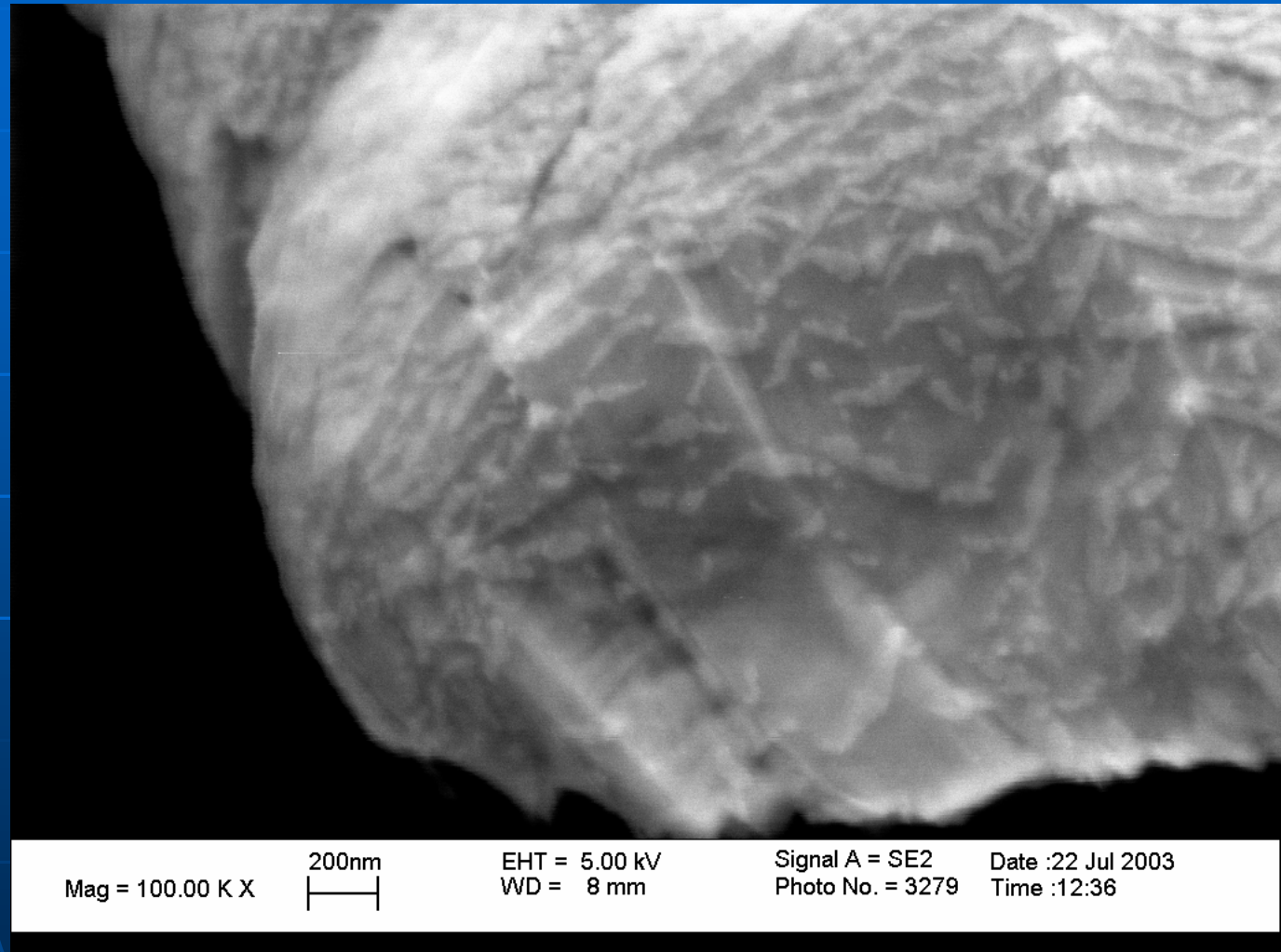
or reptilian?



Mechanical Behavior Of Electrodeposited Copper Film at Elevated Temperatures

Results: Fractography (4), end view

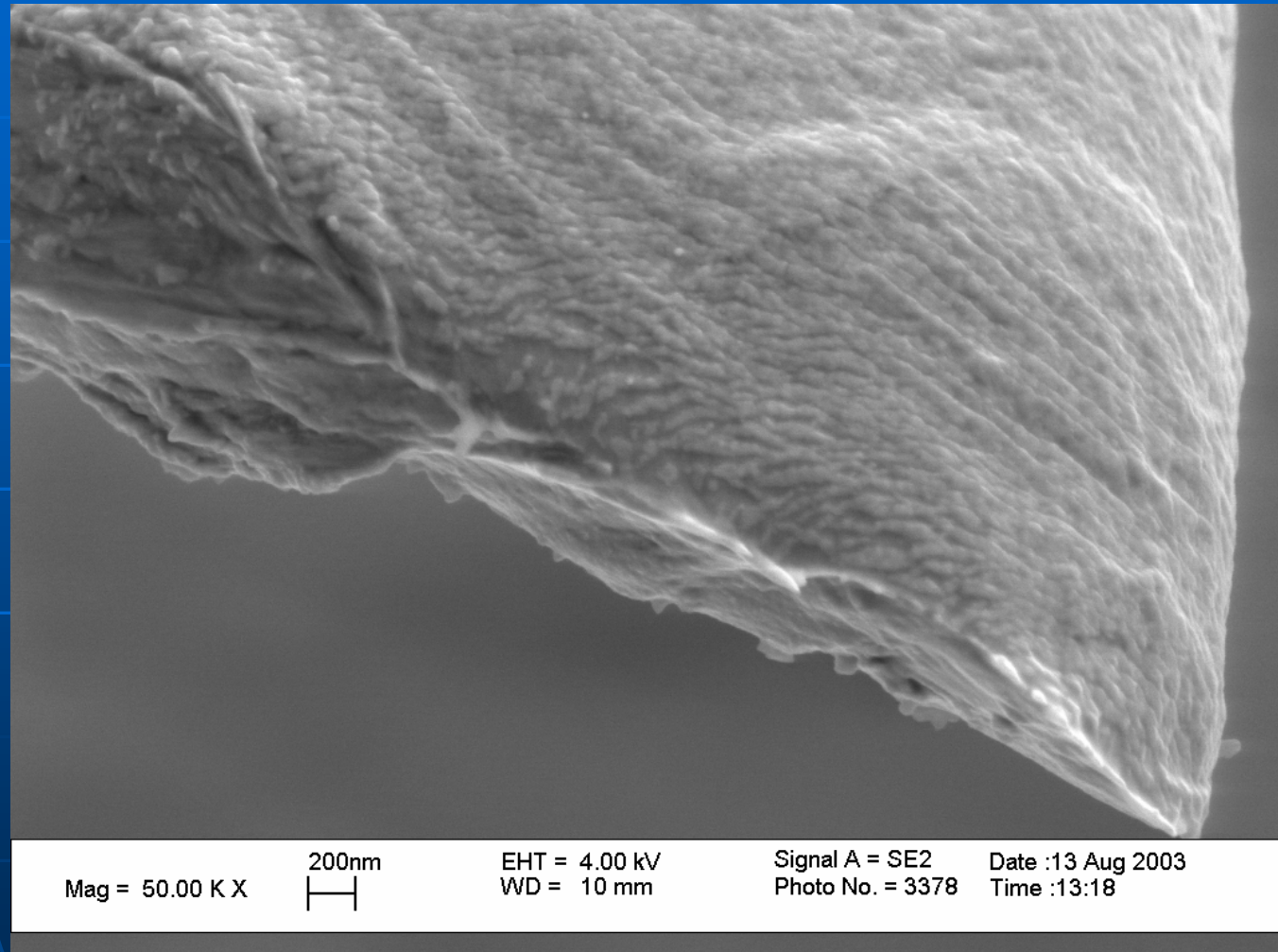
Strange surface
features—
Mud cracks?



Mechanical Behavior Of Electrodeposited Copper Film at Elevated Temperatures

Results: Fractography, end view: (6)

Strange surface
features—
Mud cracks?



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